## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Vladimir Pavlovich POPOV, et al. Serial No.: 10/542,123 Group No.: 2823 Filed: December 9, 2005 Examiner: Q. Jefferson METHOD FOR PRODUCING A SILICON-ON-INSULATOR STRUCTURE For: Attorney Docket No.: U 015850-2 Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 OK TO ENTER: /QJ/ CERTIFICATE OF MAILING/TRANSMISSION (37 CFR 1.8a) I hereby certify that this correspondence is, on the date shown below, being: **MAILING FACSIMILE** deposited with the United States Postal Service transmitted by facsimile to the Patent and with sufficient postage as first class mail in an Trademark Office to (571)-273-8300 envelope addressed to the Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450

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